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Signature: Linda M. West

PATENT
Docket No. P1572

IN THE
UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S): JENNIFER WANG
HUI-MIN SHENG
MIKE BARSKY

SERIAL NO.: 10/782,723 EXAMINER: KIN-CHAN CHEN

FILED: FEBRUARY 18, 2004 ART UNIT: 1765

FOR: DRY ETCHING PROCESS FOR COMPOUND SEMICONDUCTORS

MAIL STOP AMENDMENT
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

TRANSMITTAL LETTER

Dear Sir:

In connection with the above-referenced patent application, transmitted herewith are
the following:

1. Response to Office Action Restriction Requirement (2 pages); and
2. Post card in acknowledgment of receipt of all transmitted materials.

Please date stamp and return the enclosed post card to the undersigned in acknowledgment of receipt of all transmitted materials.

Respectfully submitted,

A handwritten signature in dark ink, appearing to read 'F. David LaRiviere', with a long horizontal flourish extending to the right.

F. David LaRiviere
Reg. No. 27,207

FDL/pa

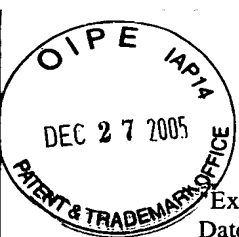
Date: 12-27-05

LARIVIERE, GRUBMAN & PAYNE, LLP

P.O. Box 3140

Monterey, CA 93942-3140

(831) 649-8800



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ELECTION IN RESPONSE
TO OFFICE ACTION RESTRICTION REQUIREMENT
UNDER 35 C.F.R. § 121

To the Commissioner:

In response to the Office Action Restriction Requirement, dated December 9, 2005, under 35 C.F.R. § 121, the Applicant request favorable consideration of the below-submitted election and remarks.